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Inventor Information for 10/733761

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US 20050051433 A1	US- PGPUB	20050310	22	Method and apparatus for monitoring, dosing and distribution of chemical solutions	205/82		Zdunek, Alan D. et al.
US 20040159351 A1	US- PGPUB	20040819		Micro electromechanical systems for delivering high purity fluids in a chemical delivery system	137/240		Znamensky, Dmitry et al.
US 20030111346 A1	US- PGPUB	20030619		Micro structured electrode and method for monitoring wafer electroplating baths	204/480		Zdunek, Alan D.
US 20020152797 A1	US- PGPUB	20021024	18	Gas delivery apparatus and method for monitoring a gas phase species therein	73/23.2		McAndrew, James J.F. et al.
US 20010017300 A1	US- PGPUB	20010830		Corrosion resistant gas cylinder and gas delivery system	220/581	220/660	Zdunek, Alan D. et al.
US 20010001441 A1	US- PGPUB	20010524		Method and apparatus for measuring coating quality	205/791	204/404; 204/434; 205/776.5	Zdunek, Alan D. et al.
US 7022212 B2	USPAT	20060404		Micro structured electrode and method for monitoring wafer electroplating baths	204/400	204/280; 204/407; 204/416; 204/434; 422/82.01; 422/82.02; 422/82.03; 422/98	Zdunek; Alan D.
US 6421127 B1	USPAT	20020716		Method and system for preventing deposition on an optical component in a spectroscopic sensor	356/437	356/246; 356/440; 359/509; 359/512	McAndrew; James J. F. et al.
US 6365227 B2	USPAT	20020402		Corrosion resistant gas cylinder and gas delivery system	427/239	427/377; 427/380; 427/437; 427/438	Zdunek; Alan D. et al.
US 6290088	USPAT	20010918		Corrosion resistant gas	220/586	106/1.22;	Zdunek;

B1				cylinder and gas delivery system		106/1.27; 220/62.11	Alan D. et al.
US 6263904 B1	USPAT	20010724		Corrosion resistant gas cylinder and gas delivery system	137/375	118/728; 137/883; 251/368; 427/305	Zdunek; Alan D. et al.
US 6207030 B1	USPAT	20010327		Apparatus for measuring coating quality	204/434	204/286.1; 204/297.1; 204/404; 205/776.5; 205/791; 294/19.1; 73/866.5	Zdunek; Alan D. et al.
US 6106693 A	USPAT	20000822		Method for measuring coating quality	205/791	204/434; 205/776.5	Zdunek; Alan D. et al.
US 5954940 A	USPAT	19990921		Method for measuring coating quality	205/776.5	204/279; 204/404; 204/434; 205/775.5; 294/19.1; 73/866.5	Zdunek; Alan D. et al.
US 5714678 A	USPAT	19980203		Method for rapidly determining an impurity level in a gas source or a gas distribution system	73/31.03	73/23.2	Jurcik; Benjamin et al.